

<b>Notice of References Cited</b>	Application/Control No. 10/655,854	Applicant(s)/Patent Under Reexamination REIF ET AL.	
	Examiner Leonardo Andújar	Art Unit 2826	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,600,173 B2	07-2003	Tiwari, Sandip	257/74
	B	US-6,525,415 B2	02-2003	Koyanagi et al.	257/686
	C	US-5,902,118 A	05-1999	Hubner, Holger	438/106
	D	US-5,904,562 A	05-1999	Nulman, Jaim	438/654
	E	US-5,706,578	01-1998	Hubner, Holger	29/830
	F	US-5,504,376 A	04-1996	Sugahara et al.	257/768
	G	US-4,939,568	07-1990	Kato et al.	257/686
	H	US-5,998,808 A	12-1999	Matsushita, Takeshi	257/74
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.